

<p style="text-align: center;">INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i></p> <p style="text-align: right; font-size: small;">MAY 8 2006</p> <p style="text-align: right; font-size: small;">U.S. PATENT AND TRADEMARK OFFICE</p>				Docket Number (Optional) H 2182		Application Number 10/047,556	
				Applicant(s) Martin Klein et al.			
				Filing Date October 23, 2001		Group Art Unit 2884	
				U.S. PATENT DOCUMENTS			
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
U.S. PATENT APPLICATION PUBLICATIONS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS							
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation
							YES
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
SL		Advances in Gas Avalanche Photomultipliers - A. Breskin et al., Dept. of Particle Physics, The Weizmann Institute of Science 76100, Rehovot, Isreal - Presented at Beaune99, The Second International Conference on New Developments in Photodetection, Beaune, France, June 21-25, 1999.					
EXAMINER <i>/Shun Lee/</i>				DATE CONSIDERED			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							